

In re Application of:

RYO KURODA ET AL.

Application No.: 10/648,317

Filed: August 27, 2003

For: NEAR-FIELD PHOTOMASK ,NEAR-FIELD  
EXPOSURE APPARATUS USING THE  
PHOTOMASK, DOT PATTERN FORMING METHOD  
USING THE EXPOSURE APPARATUS, AND  
DEVICE MANUFACTURE USING THE METHOD

Docket No. 03560.003343

Examiner: John S. Ruggles

Group Art Unit: 1756

November 14, 2005  
(Monday)

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	11	MINUS	20	0	x \$25 \$50	0
INDEP. CLAIMS	1	MINUS	3	0	x\$100 \$200	0
Fee for Multiple Dependent claims \$180/\$360						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						0

- °Verified Statement claiming small entity status is enclosed, if not filed previously.
  - A check in the amount of \$\_\_\_\_ is enclosed.
  - Charge \$\_\_\_\_ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
- Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
- A check in the amount of \$\_\_\_\_ to cover the fee for a \_\_\_\_ month extension is enclosed.
  - A check in the amount of \$\_\_\_\_ to cover the Information Disclosure Statement fee is enclosed.
- Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.



Attorney for Applicants  
Jack S. Cubert  
Registration No. 24,245

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3800  
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03560.003343

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Ryo KURODA et al.

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METHOD USING THE EXPOSURE APPARATUS,  
AND DEVICE MANUFACTURED USING THE  
METHOD

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: Examiner: John S. Ruggles  
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**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action dated August 12, 2005, please amend the above-identified application as follows: